

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

SHIOYA et al

Serial No.:

Filed: April 8, 2005

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE  
SAME

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the captioned application as follows: